Atty. Dkt. No. 039262-0165



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

plicant:

Tadahiro OHMI et al

Title:

PLASMA PROCESSING METHOD AND METHOD FOR

MANUFACTURING AN ELECTRONIC DEVICE

Appl. No.:

10/594,895

Filing Date:

11/07/2006

Examiner:

Valerie N. Brown

Art Unit:

2829

Confirmation No.:

8302

## **AMENDMENT AND REPLY UNDER 37 C.F.R. 1.111**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir:

This communication is responsive to the non-final Office Action dated July 7, 2010, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 4 of this document.

Please amend the application as follows: